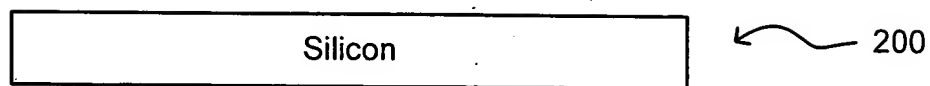
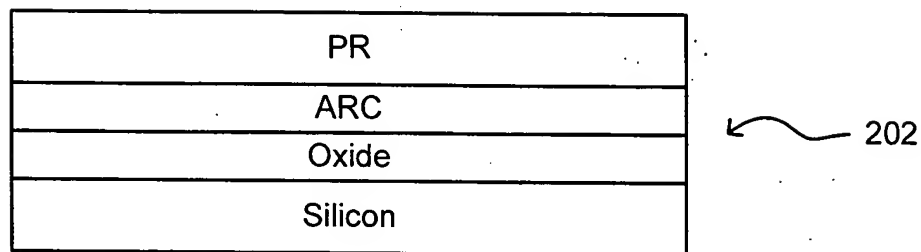


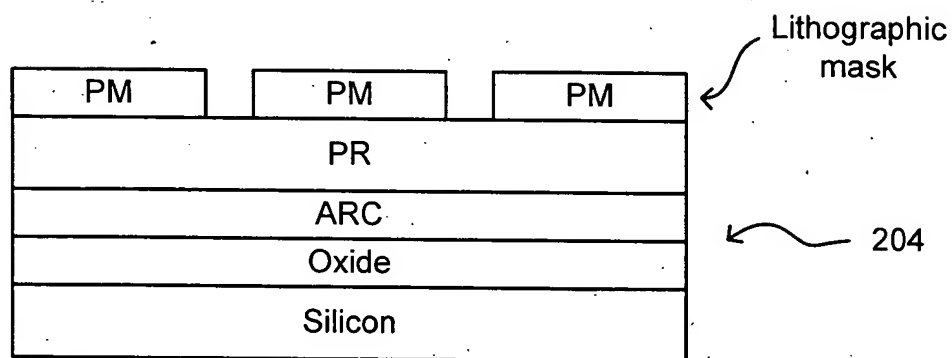
Figure 1



(a)



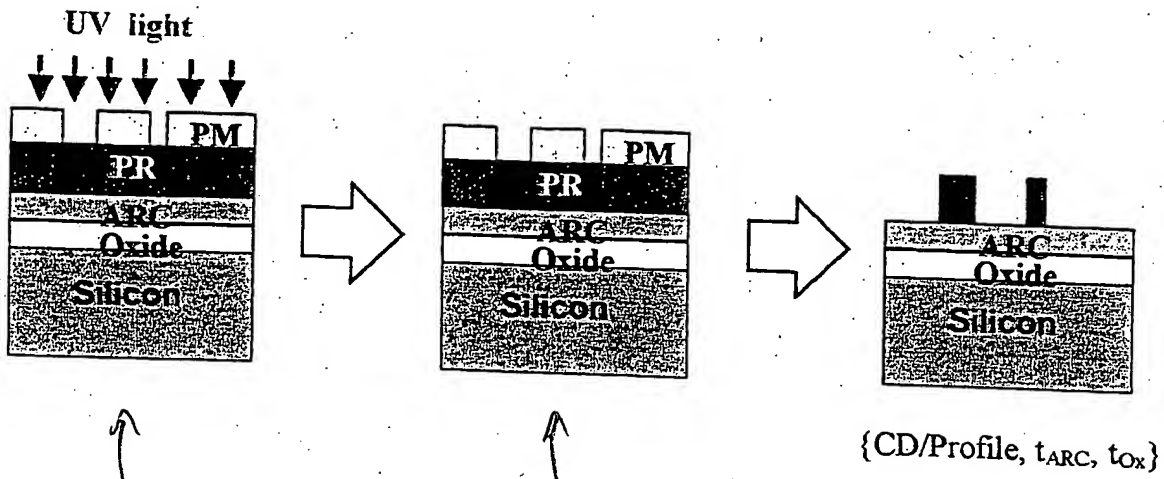
(b)



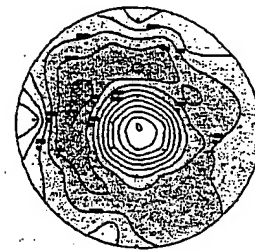
(c)

Figure 2

Lithography



Optical
scatterometry
measurements



CD_{PR}

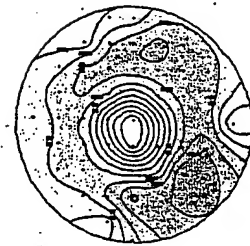
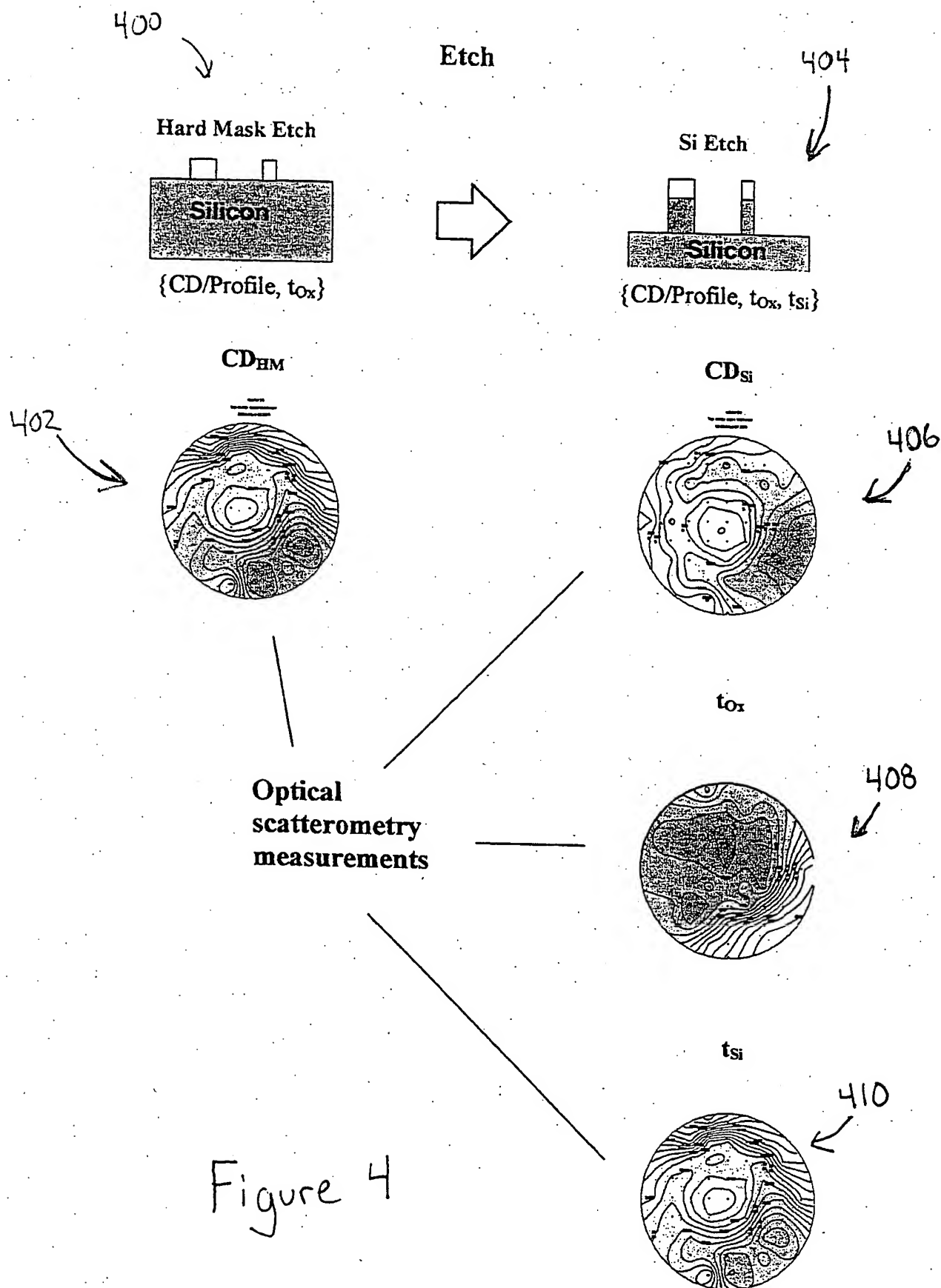


Figure 3



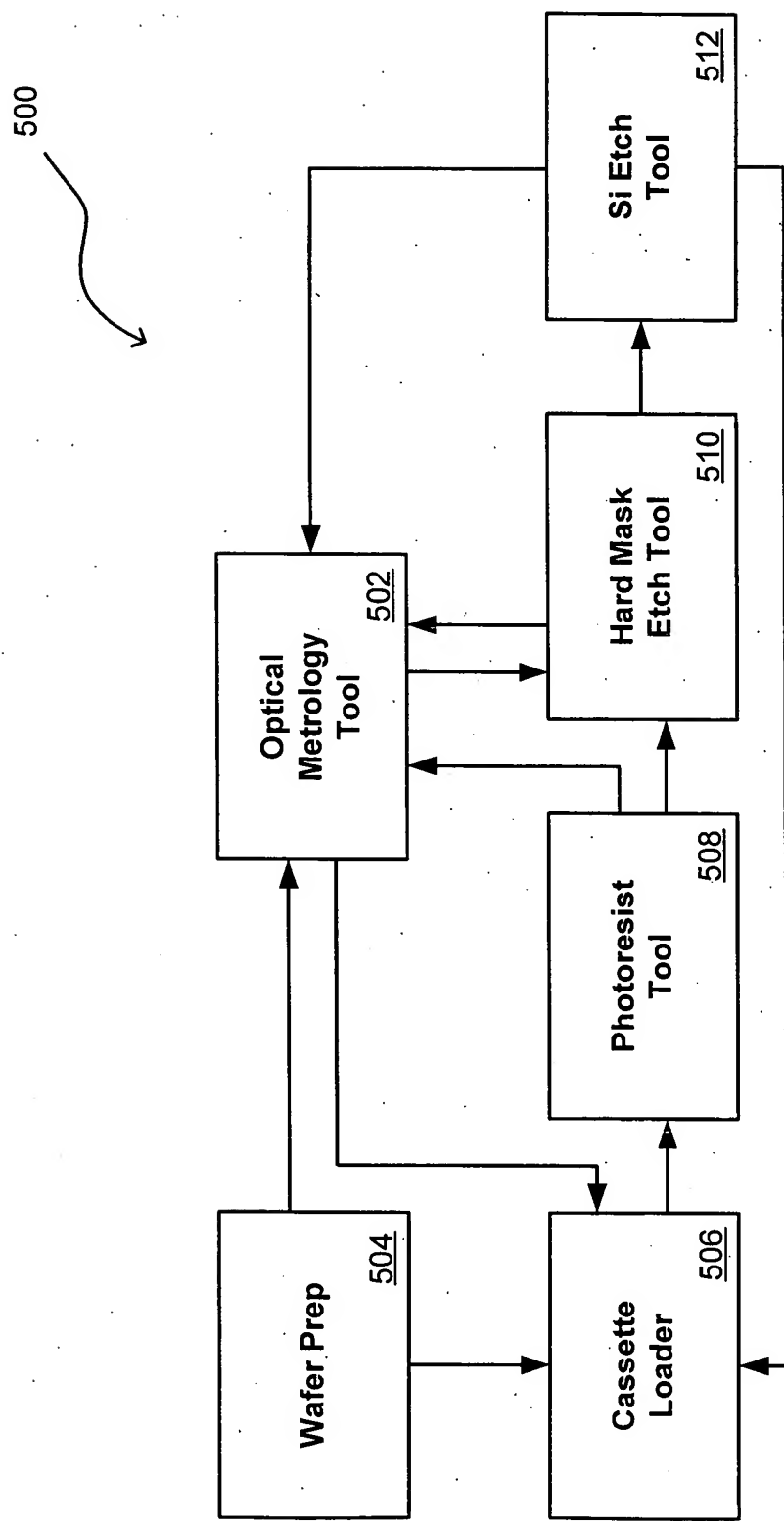


Figure 5

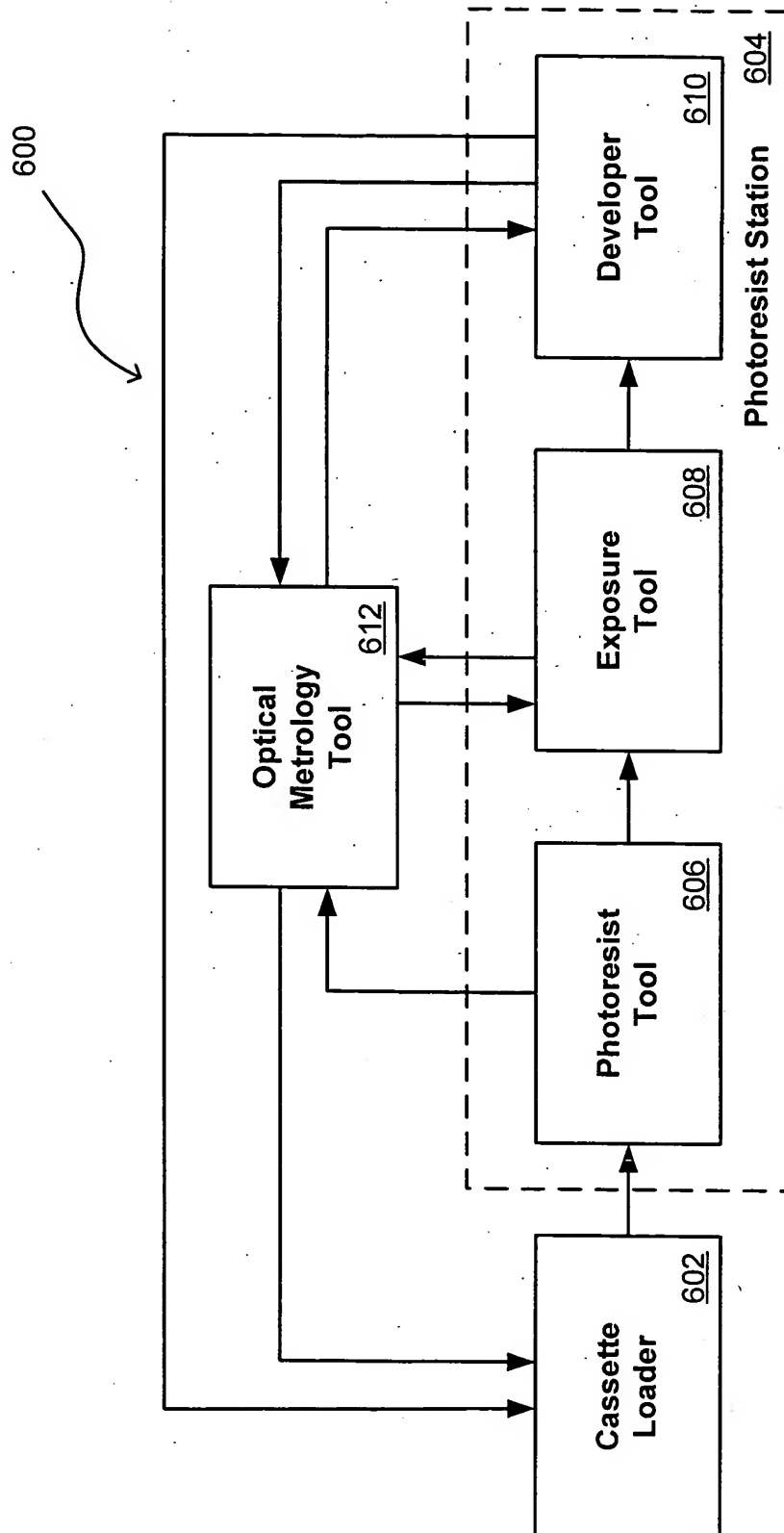


Figure 6

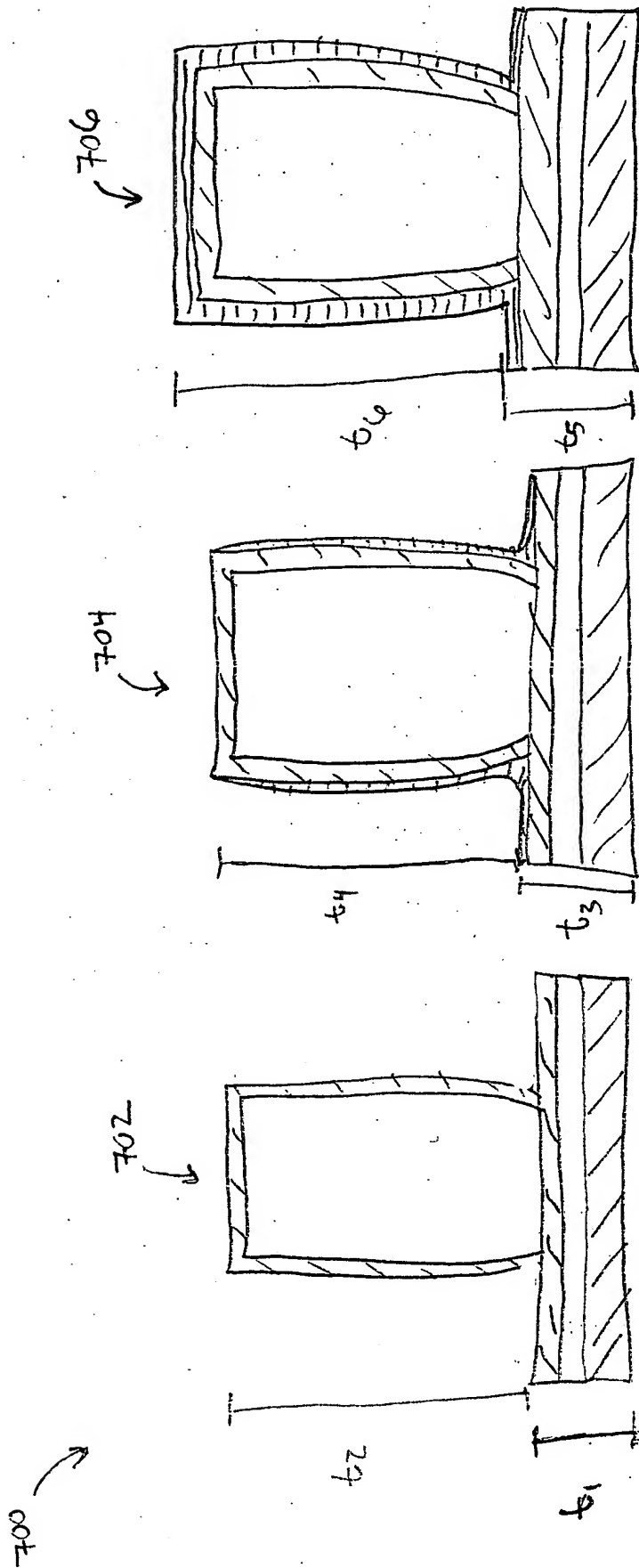


Figure 7